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## \*\* CONTINUING DATA \*\*\*\*\*

*NONE w/B*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

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*w/B*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Verified and Acknowledged	<i>Williams M. Amerson</i> Examiner's Signature	GERMANY	4	16	2

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## TITLE

Semiconductor device having an improved strained surface layer and method of forming a strained surface layer in a semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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